

# Double negatively charged carbon vacancy at the h- and k-sites in 4H-SiC: Combined Laplace-DLTS and DFT study

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We present results from combined Laplace-Deep Level Transient Spectroscopy (Laplace-DLTS) and density functional theory studies of the carbon vacancy ( $V_C$ ) in n-type 4H-SiC. Using Laplace-DLTS, we were able to distinguish two previously unresolved sub-lattice-inequivalent emissions, causing the broad  $Z_{1/2}$  peak at 290 K that is commonly observed by conventional DLTS in n-type 4H-SiC. This peak has two components with activation energies for electron emission of 0.58 eV and 0.65 eV. We compared these results with the acceptor levels of  $V_C$  obtained by means of hybrid density functional supercell calculations. The calculations support the assignment of the  $Z_{1/2}$  signal to a superposition of emission peaks from double negatively charged  $V_C$  defects. Taking into account the measured and calculated energy levels, the calculated relative stability of  $V_C$  in hexagonal ( $h$ ) and cubic ( $k$ ) lattice sites, as well as the observed relative amplitude of the Laplace-DLTS peaks, we assign  $Z_1$  and  $Z_2$  to  $V_C(h)$  and  $V_C(k)$ , respectively. We also present the preliminary results of DLTS and Laplace-DLTS measurements on deep level defects (ET1 and ET2) introduced by fast neutron irradiation and He ion implantation in 4H-SiC. The origin of ET1 and ET2 is still unclear. Published by AIP Publishing. <https://doi.org/10.1063/1.5011124>

## I. INTRODUCTION

Deep level defects that act as charge carrier traps have a high importance in the semiconductor industry and applications of semiconductor devices. These defects are mainly created during (i) semiconductor material growth, (ii) processing by ion implantation, or (iii) operation in a harsh ionizing radiation environment. In this work, we investigate electron emissions from double negatively charged vacancies in 4H-SiC, which are important electron traps already present in as-grown materials. We also report on defects created in N-doped epitaxial 4H-SiC thin layers irradiated with fast neutrons and implanted with accelerated  $\text{He}^{2+}$  ions using a fast-scanning reduced-rate ion microbeam. Silicon carbide has attracted a lot of attention as a material for power electronics with extremely low loss.<sup>1–3</sup> Besides, silicon carbide is expected to be used in the fabrication of electronic devices with high radiation resistance, capable to be used in accelerators and nuclear facilities, as well as in space applications.<sup>4–7</sup>

For the development of SiC-based devices used in radiation environments, it is very important to understand the effects of accumulated radiation damage on the electronic properties of these devices. Therefore, radiation induced defects, especially those limiting the carrier lifetime, and by

that way degrading the performance in terms of charge collection efficiency, need to be fully understood. Deep level defects known as  $Z_{1/2}$  are known as one of the most stable defects in 4H-SiC acting as strong minority carrier recombination centers in n-type materials.<sup>8–11</sup>  $\text{EH}_{6/7}$  carrier traps are also known as stable defects and are observed together with  $Z_{1/2}$  in 4H-SiC.<sup>8–11</sup> Son *et al.* ascribed both  $Z_{1/2}$  and  $\text{EH}_{6/7}$  to ( $=/0$ ) and ( $0/+$ ) transitions from the single carbon vacancy ( $V_C$ ) in 4H-SiC.<sup>12</sup> Despite being able to distinguish  $V_C$  defects at  $k$ - and  $h$ -sites in the electron paramagnetic resonance (EPR) spectra, i.e.,  $V_C(k)$  and  $V_C(h)$ , respectively, conventional deep level transient spectroscopy (DLTS) was not able to resolve the two corresponding defects from the main  $Z_{1/2}$  band. Hemmingsson and co-workers<sup>13</sup> had previously connected  $Z_{1/2}$  to a pair of metastable acceptor levels, labeled  $Z_1(-/0)$  and  $Z_2(-/0)$ , but despite the efforts, there is no hard evidence that the stable  $Z_{1/2}$  peak is made of more than one defect configuration. This has limited a direct link between the EPR and DLTS data.

In this paper, we report the results of DLTS and Laplace-DLTS studies of deep levels attributed to the carbon vacancy in N-doped 4H-SiC. We also report the acceptor levels of  $V_C$  by means of hybrid density functional supercell calculations. We show that the negative- $U$  ordering of  $V_C$  acceptors results from strong atomic relaxations that take

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place after carrier emissions. The calculations support the assignment of the  $Z_{1/2}$  signal to a superposition of emission peaks from double negatively charged  $V_C$  defects. Comparison of the calculations with the Laplace-DLTS data allows us to assign inequivalent sub-lattice sites to  $Z_1$  and  $Z_2$ .

## II. EXPERIMENTAL AND THEORETICAL DETAILS

n-type silicon carbide Schottky barrier diodes (SBDs) were fabricated on nitrogen-doped epitaxial grown 4H-SiC single crystal layers approximately 25  $\mu\text{m}$  thick.<sup>14</sup> The Schottky barrier was formed by evaporation of nickel through a metal mask with patterned square apertures of 1 mm  $\times$  1 mm, while Ohmic contacts were formed by nickel sintering at 950 °C in Ar atmosphere on the back side of the silicon carbide substrate. A reverse negative bias was connected to the front Schottky contact, while the back Ohmic contact of the 4H-SiC SBDs was grounded. The calculated free carrier concentration in pristine samples was  $\sim 5 \times 10^{14} \text{ cm}^{-3}$  across the thickness of the epitaxial layer, where a  $-10 \text{ V}$  reverse voltage applied for DLTS measurements corresponded to a depletion depth of 4.9  $\mu\text{m}$ .

Samples were irradiated inside Cd thermal neutron filters with a wall thickness of 1 mm in the pneumatic tube (F2a4) irradiation location in the 250 kW JSI TRIGA reactor in Ljubljana. The neutron spectrum in the irradiation location was characterized previously on the basis of Monte Carlo calculations with the MCNP code and activation measurements.<sup>15,16</sup> Three power levels (2.5 W, 25 W, and 250 kW) were used for neutron irradiations in the  $10^8$  to  $10^{15} \text{ cm}^{-2}$  nominal fluence range. Activation measurements for the  $^{197}\text{Au}(n,\gamma)$  reaction were performed for each power level activation in order to deduce the total neutron flux. The sub-cadmium flux was obtained from the characterized neutron spectrum and the Cd cutoff energy for the thickness of 1 mm, i.e., 0.55 eV. Table I reports details of the neutron irradiation conditions for the selected samples. The calculated uncertainties in the neutron fluences were obtained from uncertainties in the neutron flux and the irradiation time.

Selected pristine as-prepared samples were pattern-implanted with 2 MeV  $\text{He}^{2+}$  ions using a fast-scanning micro-beam at the ANSTO nuclear microprobe facility<sup>17</sup> in order to generate isolated ion collision cascades in the 4H-SiC layers. According to SRIM<sup>18</sup> simulations, the stopping range of the  $\text{He}^{2+}$  implants was approximately  $4.7 \pm 0.1 \mu\text{m}$ . This was chosen to obtain an atomic displacement density distribution within the depletion region of the reversely biased SBDs examined using deep-level transient spectroscopy (DLTS).

DLTS measurements were carried out on a Sula Technologies deep level spectrometer in the temperature range up to 380 K, in vacuum and in the absence of light. All DLTS and Laplace-DLTS measurements were done using a reverse bias voltage of  $-10 \text{ V}$ , with a 9.9 V pulse lasting 10 ms. Laplace-DLTS has higher energy resolution (usually a few meV) than conventional DLTS and has been successful in revealing information on the local environment of defects and impurities, such as strain fields or atomic siting. The Laplace-DLTS spectra were obtained from capacitance transients by the Flog numerical routine. Each calculated spectrum contains 200 points. Capacitance transients were recorded using a Boonton 7000 capacitance meter in temperature range 282–300 K with a 2 K step. At each temperature, capacitance transient measurements took few minutes; sampling rates were in the range 8–60 kHz with a total number of samples around  $3 \times 10^4$ .

Density functional calculations were carried out using the VASP code package.<sup>19</sup> We employed the projector-augment wave method to describe the core electrons,<sup>20</sup> while a plane-wave basis with kinetic energy up to 400 eV was used to describe the Kohn-Sham electronic states. The exchange-correlation potential was evaluated using the hybrid density functional of Heyd-Scuseria-Ernzerhof (HSE06),<sup>21</sup> which mixes semi-local and exact exchange interactions at short ranges, treating the long-range interactions within the simpler generalized gradient approximation (GGA).<sup>22</sup> HSE06-level energies were obtained from pre-relaxed defect structures using the GGA for the exchange-correlation energy.

TABLE I. Samples used for this study, neutron irradiation, and ion implantation conditions. Top: neutron irradiation details (sample ID, irradiation time, reactor power, sub-cadmium neutron flux and uncertainty, and sample neutron fluence). Bottom: ion implantation details (sample ID, ion type, rate/pixel dwell time, ion energy, and fluence).

Sample ID	Irr. Time (s)	Power (W)	Sub-Cd flux ( $\text{n cm}^{-2} \text{ s}^{-1}$ ), Unc. (%)	Fluence ( $\text{n cm}^{-2}$ ), Unc. (%)
R6	3.0	2.5	$3.66 \times 10^7$ (2.7%)	$1.10 \times 10^8$ (9.8%)
R10	30	2.5	$3.66 \times 10^7$ (2.7%)	$1.10 \times 10^9$ (2.9%)
R11	300	2.5	$3.66 \times 10^7$ (2.7%)	$1.10 \times 10^{10}$ (2.7%)
R9	273	25	$3.44 \times 10^8$ (2.9%)	$9.39 \times 10^{10}$ (2.9%)
R12	2730	25	$3.44 \times 10^8$ (2.9%)	$9.39 \times 10^{11}$ (2.9%)
1E13	2.73	250 000	$3.66 \times 10^{12}$ (2.7%)	$1.00 \times 10^{13}$ (10.7%)
1E14	27.3	250 000	$3.66 \times 10^{12}$ (2.7%)	$1.00 \times 10^{14}$ (2.9%)
1E15	273	250 000	$3.66 \times 10^{12}$ (2.7%)	$1.00 \times 10^{15}$ (2.7%)
Sample ID	Ion	Rate (kHz)/pixel dwell time (ms)	Ion En. (MeV)	Fluence ( $\text{cm}^{-2}$ )
R1			Pristine	
R13	$\text{He}^{2+}$	5/0.1	2.0	$5 \times 10^8$
R14	$\text{He}^{2+}$	5/0.1	2.0	$1 \times 10^9$
R15	$\text{He}^{2+}$	5/0.1	2.0	$2 \times 10^9$
R16	$\text{He}^{2+}$	5/0.1	2.0	$5 \times 10^9$

Vacancy defects were inserted in 576-atom supercells, corresponding to  $6 \times 6 \times 2$  unit cells of  $4H$ -SiC with lattice parameters  $a = 3.071 \text{ \AA}$  and  $c = 10.052 \text{ \AA}$ , and the Brillouin zone was sampled at  $\mathbf{k} = (0 \ 0 \ 1/2)$ . We found this particular sampling scheme to provide energy differences with an error bar of about 5 meV (when compared to results obtained using a  $2 \times 2 \times 2$  sampling grid). Further, in GGA calculations that used the  $\mathbf{k} = (0 \ 0 \ 1/2)$  point, we did not find artificial hybridizations between defect levels lying high in the gap and the conduction band states. This effect takes place at  $\mathbf{k} = \Gamma$  due to the underestimation of the bandgap width.

Energy levels were obtained by comparing the electron affinity of defective supercells with the same quantity for a bulk supercell. The latter quantity is representative of the conduction band minimum energy. Total energies of charged supercells were adjusted by a periodic charge correction.<sup>23</sup>

### III. RESULTS AND DISCUSSION

The ground state structures of carbon vacancy ( $V_C$ ) defects obtained from hybrid density functional calculations are summarized in Fig. 1(a). The structure of the vacancy is sensitive to the pseudo-Jahn-Teller effect, which depends on the charge state.<sup>24–26</sup> The Si atoms bordering the vacancy in structures B, C, and D define tetrahedra possessing, respectively, 2, 1, and 3 Si-Si edges distinctively shorter among a total of 6.<sup>26</sup> These are represented by thick segments in Fig. 1(a).

For  $V_C$  at the  $k$ -site, we found that irrespectively of the Fermi level location, only  $V_C^0(k)$  and  $V_C^-(k)$  states are stable (the negative charge state always has higher formation energy than neutral and double minus charge states), and the  $(=0)$  transition takes place at about  $E_c - 0.63 \text{ eV}$ . This means that the acceptor levels of  $V_C(k)$  show an inverted order (commonly referred to as negative- $U$  ordering). Metastable transitions involving the  $V_C^-$  state, namely,  $E(-/0)$  and  $E(=/-)$ , are calculated at  $E_c - 0.61 \text{ eV}$  and  $E_c - 0.64 \text{ eV}$ , respectively, and can be visualized in the configuration coordinate diagram of Fig. 1(b), where it becomes clear that the  $V_C^- \rightarrow V_C^0 + e^-$  electronic emission involves a change from structure D to structure B.

The vacancy at the  $h$ -site has electronic transitions very close to those of  $V_C(k)$ .  $E(-/0)$  and  $E(=/-)$  levels are calculated at  $E_c - 0.67 \text{ eV}$  and  $E_c - 0.64 \text{ eV}$ , respectively. We note, however, that although in this case the calculated

$U$ -value is positive, it is nearly zero. Considering a typical error bar of 0.1 eV in the calculation of levels, our results are also consistent with the observation suggesting  $V_C(h)$  being a negative- $U$  defect like  $V_C(k)$ .<sup>26</sup> An important difference between  $V_C(k)$  and  $V_C(h)$  is the fact that the ground state of  $V_C^-(h)$  adopts structure C (while D is now metastable by 0.14 eV). We note that the barriers for  $C \leftrightarrow D$  conversion were calculated to be 0.06 eV and 0.17 eV for  $V_C^-(k)$  and  $V_C^-(h)$ , respectively [see Fig. 1(b)]. This implies that both C and D structures could be involved in the emission process at the temperatures of DLTS measurements (close to 300 K). If that is the case, and structure D of  $V_C^-(h)$  is accessible during DLTS measurements, electron emissions from  $V_C^-$  and  $V_C^0$  are anticipated to have energies of 0.64 eV and 0.53 eV, respectively, and therefore showing a negative- $U$  ( $=/0$ ) level at  $E_c - 0.59 \text{ eV}$ .

We found that the carbon vacancy in  $4H$ -SiC is invariably more stable at the  $k$ -site than at the  $h$ -site, irrespectively of its charge state. Accordingly, the energies of  $V_C^0$ ,  $V_C^-$ , and  $V_C^{2-}$  were found to be 0.13 eV, 0.06 eV, and 0.06 eV lower for site- $k$  than for site- $h$ . This suggests that in as-grown materials, the population of  $V_C(k)$  defects should be larger than that of  $V_C(h)$ .

Figure 2 shows DLTS spectra of as-grown, neutron irradiated, and  $\text{He}^{2+}$  implanted samples. In the as-grown sample, only one peak is observed. The estimated activation energy for electron emission was 0.64 eV. This defect, known as  $Z_{1/2}$ , has been reported for numerous times as the most dominant defect in as-grown  $4H$ -SiC and was ascribed to the carbon vacancy.<sup>12</sup>

The  $Z_{1/2}$  DLTS peak has been claimed to result from a superposition of two overlapping peaks associated with  $Z_1$  and  $Z_2$  defects, ascribed to  $V_C$  defects on both sub-lattice sites of  $4H$ -SiC. It is generally accepted that they are both negative- $U$  double acceptors. Indeed, this assignment is strongly supported by our calculated  $(=0)$  levels at  $E_c - 0.63 \text{ eV}$  and  $E_c - 0.59 \text{ eV}$  for  $V_C(k)$  and  $V_C(h)$ , respectively. However, due to the inherent limitations in the resolution of conventional DLTS,  $Z_1(=0)$  and  $Z_2(=0)$  double-emissions could not be resolved.

The above view means that under equilibrium conditions,  $V_C$  defects can trap two electrons but not one. Hence,

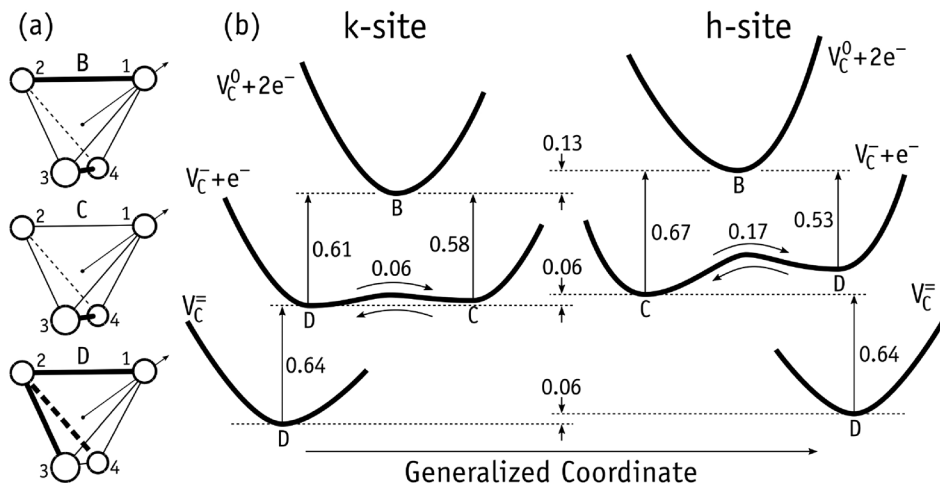


FIG. 1. (a) Diagrams of vacancy structures B, C, and D. Shorter Si-Si distances are shown as thick lines. The arrow passing through Si<sub>1</sub> is parallel to the  $c$ -axis. (b) Configuration coordinate diagram of  $V_C$  in  $n$ -type  $4H$ -SiC (energies are in eV).

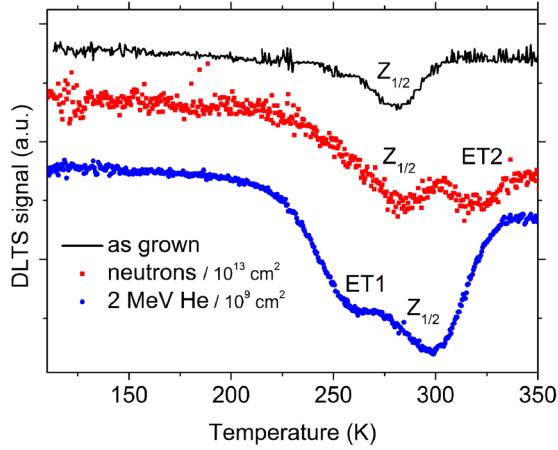


FIG. 2. DLTS spectra of as-grown, as well as selected neutron-irradiated and He-ion implanted samples. Measurement settings are reverse bias voltage  $-10$  V, pulse height  $9.9$  V, pulse width  $10$  ms, and time window  $100$  ms.

electron emission proceeds as a two-stage mechanism ( $V_C^- \rightarrow V_C^- + e^- \rightarrow V_C^0 + 2e^-$ ), which cannot be resolved by single-pulse DLTS measurements. Only the emission of the deeper level is detected as the rate-limiting step.<sup>27</sup> The emission of the second and more weakly bound electron could be resolved by applying a double pulse sequence of a short voltage pulse followed by pumping the sample with an optical pulse.<sup>13,28</sup>

We applied the Laplace-DLTS technique in order to resolve  $Z_1(=0)$  and  $Z_2(=0)$  in  $4H$ -SiC. In a previous work, Koizumi *et al.* were able to resolve electron emissions from the carbon vacancy at three sites, namely,  $k_1$ ,  $k_2$ , and  $h$ , in the  $6H$  polytype of SiC.<sup>29</sup> Here we look at the analogous problem for the uncharted case of  $Z_{1/2}$  in  $4H$ -SiC.

Figure 3 shows the Laplace-DLTS spectra for the as-grown sample. Two peaks could be clearly separated, and their activation energies for electron emission were determined as  $E_c - 0.58$  eV and  $E_c - 0.65$  eV from the Arrhenius plot shown in Fig. 4 of  $T^2$ -corrected electron emission rates. These energies are in good agreement with those reported by Hemmingson *et al.*,<sup>13</sup> and for the sake of labelling consistency, and based on their relative position in the gap, we,

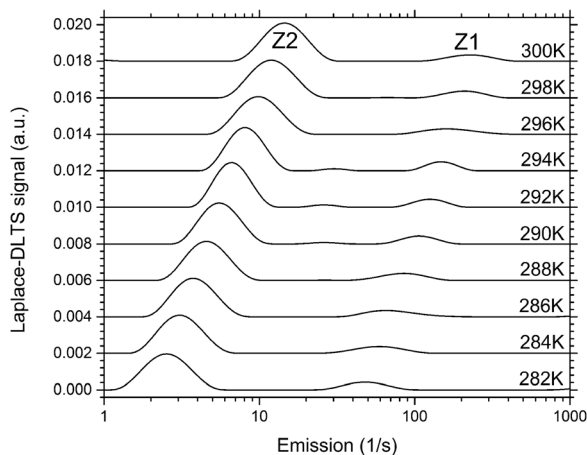


FIG. 3. Laplace-DLTS spectra for an as-grown sample measured at temperatures in the range of  $282$ – $300$  K. Measurement settings are reverse bias voltage  $-10$  V, pulse height  $9.9$  V, and pulse width  $10$  ms.

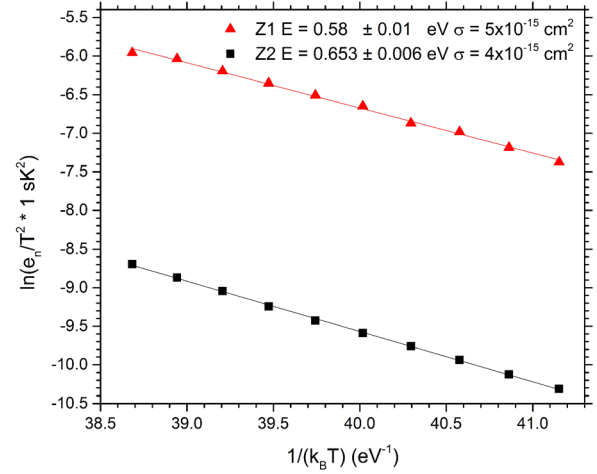


FIG. 4. Arrhenius plots of  $T^2$ -corrected electron emission rates for the  $Z_1$  and  $Z_2$  defects observed in the Laplace-DLTS spectrum of the as-grown sample.

respectively, refer to them as  $Z_1$  and  $Z_2$ . Other physical parameters such as the capture cross section and concentration of both  $Z_1$  and  $Z_2$  have also been calculated from Laplace-DLTS measurements and are given in Table II.

Interestingly, we found the  $[Z_1]:[Z_2]$  intensity ratio to be  $1:5$ , in contrast to  $1:1$  or  $1:2$  as previously reported for as-grown  $4H$ -SiC samples.<sup>13,28</sup> Our result suggests that the ratio is likely to depend on growth conditions, thermal history, and/or doping of the sample. This is supported by the strong charge-state dependence of the relative stability of  $V_C(k)$  and  $V_C(h)$  obtained from the DFT calculations.

Ion implantations and fast neutron irradiations have introduced new deep levels which are evidenced by changes in the DLTS spectra as shown in Fig. 2. They could be summarized as follows:

- (i) He-ion implantations lead to an increase of the  $Z_{1/2}$  peak and to the introduction of an additional peak (labelled as ET1). As the intensity of  $Z_{1/2}$  increased with ion fluencies, its peak maximum shifted to higher temperatures (not shown in Fig. 2). A similar shift was already observed in  $4H$ -SiC epi-layers irradiated with protons, alpha particles, and electrons, and it was interpreted as the release of stress produced by defect clusters.<sup>30,31</sup>
- (ii) For the neutron fluencies lower than  $10^{13} \text{ cm}^{-2}$ , no changes were observed (not shown in Fig. 2). For higher fluencies, the intensity of  $Z_{1/2}$  slightly increased, and another peak was introduced (labelled as ET2).

ET1 and ET2 traps were previously reported in the literature and were assigned to several defects.<sup>13,31</sup> Their low

TABLE II. Electronic properties for  $Z_1$  and  $Z_2$  estimated from Laplace-measurements, namely, the energy position  $E$ , the effective electron capture cross section  $\sigma_n$ , and the defect concentration  $N_t$ .

Trap label	$E$ (eV)	$\sigma_n$ ( $\text{cm}^{-2}$ )	$N_t$ ( $\text{cm}^{-3}$ )
$Z_1$	$E_c - 0.58$	$5 \times 10^{-15}$	$3 \times 10^{-11}$
$Z_2$	$E_c - 0.65$	$4 \times 10^{-15}$	$2 \times 10^{-12}$



thermal stability is the only consensual property among the earlier studies. ET1 and ET2 traps might be simple defects with low thermal stability such as carbon interstitials or Frenkel pairs since they are introduced by different radiation sources and disappear after DLTS measurements up to 700 K.<sup>32</sup> At this point, we could not determine the concentration of ET1 and ET2 in a reliable manner. This follows from the fact that ion-implants and fast-neutrons produce highly inhomogeneous damage, which was clearly seen by CV profiling measurements.<sup>32</sup>

Additionally, we performed a low-temperature annealing that did not yield any clarification regarding the origin of ET1 and ET2 peaks but only indicated a rather complex nature of the defects introduced. In a previous study,<sup>32</sup> we had shown that annealing treatments at temperature as low as 700 K introduce significant changes in implanted (H and He ions) 4H-SiC materials although the calculated activation energies for migration and transformation of intrinsic defects in 4H-SiC are considerably high.<sup>33</sup> We also reported that the changes observed in the material during such low temperature annealing treatments affect the free carrier concentration.<sup>32</sup> The observed recovery of the free carrier concentration has been connected with the transformation of as-implanted induced defects possessing a low thermal stability.

While EPR experiments were successful in distinguishing  $V_C$  defects located at  $k$ - and  $h$ -sites, that has not been the case with conventional DLTS regarding  $Z_{1/2}$ . In this respect, the high-resolution provided by Laplace-DLTS provides an opportunity to directly compare the calculated levels with the experiments. As reported above, while we calculate an  $E(=0)$  level for  $V_C(k)$  at  $E_c - 0.63$  eV, for  $V_C(h)$  we obtain  $E(-/0)$  and  $E(=/-)$  ground state transitions at  $E_c - 0.67$  eV and  $E_c - 0.64$  eV (calculated positive- $U$  value is close to zero). However, if we consider that after the 0.64 eV emission from  $V_C^-(h)$ , a second emission can immediately follow from structure D to B with an activation energy of 0.53 eV [see Fig. 1(b)], this would result in a negative- $U$  peak with energy  $E(=0)$  at  $E_c - 0.59$  eV. Hence, our results support the connection of  $V_C(k)$  to the 0.65 eV Laplace-DLTS emission ( $Z_2$ ), while  $V_C(h)$  should be assigned to the 0.58 eV peak (see Figs. 3 and 4).

Further, considering that irrespectively of the charge state,  $V_C(k)$  is always more stable than  $V_C(h)$ , and inferring that in the as-grown SiC samples the vacancy concentration is close to equilibrium, the Laplace-DLTS peak related to  $V_C(k)$  should have greater amplitude than the analogous peak related to  $V_C(h)$ . From a direct comparison of the calculated relative energies with the Laplace-DLTS peak amplitudes, we confirm the assignment of  $Z_1$  and  $Z_2$  to electron emissions from  $V_C^-(h)$  and  $V_C^-(k)$ , respectively. This assignment is also consistent with the EPR measurements from Ref. 12. Here, the  $V_C^-(h)$  EPR signal was detected in darkness upon heating the sample above 100 K, whereas observation of  $V_C^-(k)$  always required external illumination. This indicates that when the Fermi level is close to the  $(=0)$  transition,  $V_C^-(h)$  is almost as stable as other competing charge states, unlike  $V_C^-(k)$  which must be metastable.

## IV. CONCLUSIONS

We report on Laplace-DLTS measurements combined with hybrid density functional calculations of the electronic properties of the carbon vacancy in 4H-SiC. Our results demonstrate that at the origin of the  $Z_{1/2}$  DLTS band are two defects with close emission rates. These are assigned to  $Z_1(=0)$  and  $Z_2(=0)$  transitions, and they are related to previous optically pumped dual-pulse DLTS experiments,<sup>13,28</sup> which found metastable  $Z_1(-/0)$  and  $Z_2(-/0)$  peaks. Our work provides hard evidence for the assignment of  $Z_{1/2}$  to superimposed  $(=0)$  transitions of  $V_C$  located at  $k$ - and  $h$ -sites. Combining the calculations with high-resolution Laplace-DLTS data, we finally ascribe a sub-lattice site to each component of  $Z_{1/2}$ . Accordingly, by correlating measured and calculated energy levels, as well as the calculated relative stability of  $V_C$  in both sites with the relative amplitude of the Laplace-DLTS peaks, we assign  $Z_1$  and  $Z_2$  to consecutive two-electron emissions from  $V_C^-(h)$  and  $V_C^-(k)$ , respectively.

The origin of the additional ET1 and ET2 deep level defects introduced by fast neutron irradiation and He-ion implantation remains unclear and will be the subject of following studies.

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